# SPIRE Spectrometer Pipeline Description

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## **Chapter 1. Introduction**

## 1.1. Acronyms

Table 1.1. Acronyms

Short Form	Full Name	
ADC	Analog to Digital Converter	
BSM	Beam Steering Mirror	
FFT	Fast Fourier Transform	
FT	Fourier Transform	
FTS	Fourier Transform Spectrometer	
iFTS	imaging Fourier Transform Spectrometer	
ILS	Instrument Line Shape	
IPAC	Infrared Processing and Analysis Center	
JPL	Jet Propulsion Laboratory	
LHS	Left Hand Side	
LPF	Low Pass Filter	
LVDT	Linear Variable Differential Transformer	
MPD	Mechanical Path Difference	
NHKT	Nominal HouseKeeping Timeline Product	
OPD	Optical Path Difference	
QCP	Quality Control Pipeline	
RC	Resistor-Capacitor	
RHS	Right Hand Side	
RMS	Root Mean Square	
RSRF	Relative Spectral Response Function	
SBS	Spectrometer Beam Splitter	
SCAL	Spectrometer Calibrator	
SDI	Spectrometer Detector Interferogram Product	
SDS	Spectrometer Detector Spectrum Product	
SDT	Spectrometer Detector Timeline Product	
SLW	Spectrometer Long Wavelength Detector Array	
SMEC	SPIRE Spectrometer Mechanism	
SMECT	Spectrometer Mechanism Timeline Product	
SOF	Spectromter Observation Format	
SPG	Standard Product Generation	
SPIRE	Spectral and Photometric Imaging REceiver	
SPP	SPIRE Pointing Product	
SSW	Spectrometer Short Wavelength Detector Array	
TBD	To Be Determined	
TBW	To Be Written	
WTMML	Wavelet Transform Modulus Maxima Lines	
ZPD	Zero Path Difference	

## 1.2. Scope of Document

This purpose of this document is to present an outline of the processing steps in the SPIRE spectrometer pipeline. The processing modules presented in this document follow those presented in Section 3 of [AD01], which describes the steps that are common to both the SPIRE spectrometer and photometer pipelines.

## 1.3. Documents

## 1.3.1. Applicable Documents

AD01	M. Griffin, The SPIRE Analogue Signal Chain and Photometer Detector Data Processing Pipeline, SPIRE-UCF-DOC-002890, Issue 5, 01 August 2008.
AD02	C. Pearson, SPIRE Pipeline Description, SPIRE-RAL-DOC-002437, Issue 1.0, 02 August 2008.
AD03	SPIRE Observers' Manual, HERSCHEL-HSC-DOC-0789, Version 1.2, 11 September 2007, http://herschel.esac.esa.int/Docs/SPIRE/html/spire_om.html.
AD04	K. J. King, SPIRE Data Product Definition
AD05	Operating Modes for the SPIRE Instrument, SPIRE-RAL-DOC-0000320, Issue 3.3, 24 June 2005.

#### 1.3.2. Reference Documents

**RD01** 

	to SDAG 15, 10 July 2006
RD02	Sensitivity of the SPIRE Detectors to Operating Parameters, SPIRE-UCF-DOC-002901, 14 November 2007
RD03	D. A. Naylor and M. K. Tahic, "Apodizing functions for Fourier transform spectroscopy," J. Opt. Soc. Am. A 24, 3644-3648 (2007)
RD04	F. Pinsard, "HERSCHEL/SPIRE Detector Control Unit Design Document", SPIRE-SAP-PRJ-001243, Issue 1.0, 11 July 2005.
RD05	Knutsson, H. and Westin, C. F., "Normalized and Differential Convolution Methods for Interpolation and Filtering of Incomplete and Uncertain Data," Proc. Computer Vision and Pattern Recognition, 512-523, (1993).
RD06	Spencer, L. D., et. al., "Performance evaluation of the Herschel/SPIRE instrument flight model-imaging Fourier transform spectrometer," in Space Telescopes and Instrumentation I: Optical, Infrared, and Millimeter Wave, 7010, Proc. SPIE, (2008)

Jean-Paul Baluteau, PFM3b data: some SMEC or FTS performances, Presentation

## 1.4. Document History

Table 1.2. Version and Date

Issue	Date
Draft 0.1	27 March 2007
Draft 0.2	02 May 2007

Issue	Date
Draft 0.3 (was Version 1.0)	09 May 2007
Draft 0.4 (was Version 1.1)	27 June 2007
Draft 0.5 (was Version 1.2)	10 July 2007
Draft 0.6 (was Version 1.3)	31 August 2007
Draft 0.7 (was Version 1.4)	26 September 2007
Draft 0.8 (was Version 1.5)	02 October 2007
Draft 0.9 (was Version 1.6)	10 April 2008
Issue 1.0	23 May 2008

## 1.5. Change Record

Issue 1.0 to Issue 1.1

- Changed Chapter 2 to include a summary of the SPIRE Spectrometer AOTs.
- Changed Chapter 3 to describe the building block pipeline.
- Modified the "Clipping Correction" section so that it describes its current implementation.
- Modified the "Time Domain Phase Correction" section for clarity by splitting it into two sections; identification and correction. Some of the equations were also changed for clarity.
- Modified Section 3.3.3 "Second Level Deglitching" for clarity.
- Modified Section 3.3.5 "Phase Correction" for clarity.
- Corrected Equation 3.32 in Section 3.4.1 "Fourier Transform".
- Corrected Equation 3.40 in Section 3.5.1 "Spectral Response Correction".
- Corrected Equation 3.41 in Section 3.5.2 "Flux Conversion".
- Corrected Equation 3.43 and Equation 3.44 in Section 3.5.4 "Spectral Averaging".
- Added Chapter 4 "SPIRE iFTS Spectral Mapping".

# Chapter 2. SPIRE Spectrometer Pipeline Overview

The data processing pipeline for the Spectral and Photometric Imaging Receiver (SPIRE) imaging Fourier Transform spectrometer (iFTS) contains processing modules commonly used to process FTS data, such as phase correction and the Fourier transform. The SPIRE iFTS pipeline also contains processing steps unique to SPIRE, such as the correction for the Herschel Telescope and Spectrometer Calibrator (SCAL).

The SPIRE iFTS pipeline has been designed to be consistent with the astronomical observation templates (s) that are available to the users of the SPIRE spectrometer [AD05]. The final data products generated by the Spectrometer pipelines will in all cases consist of hyperspectral data; two spatial dimensions representing the astronomical region under study and one spectral dimension. The degree to which the hyperspectral data product is sampled both spatially and spectrally depends on the type of observation chosen.

## 2.1. Spatial Sampling

The spatial sampling in the final hyperspectral cubes depends on a combination of the number of requested pointing positions of the Herschel Telescope and the number of jiggle positions of the SPIRE Beam Steering Mirror (BSM) selected. The number of Herschel Telescope pointing positions, n, will depend on the observing area requested and is limited by the maximum observing time for one (18 hours [AD03]). A list of the spatial sampling options available to astronomical observers is shown in Table 2.1.

Spatial Sampling	Number of Her- schel Telescope Positions	Number of BSM Positions	Total Number of Pointing Posi- tions	Beam Spacing, SSW Band [arcsec]	Beam Spacing, SLW Band [arcsec]
Single, Sparse	1	1	1	32.5	50.5
Single, Intermediate	1	4	4	16.3	25.3
Single, Intermediate	1	16	16	8.1	12.7
Raster, Sparse	n	1	n	32.5	50.5
Raster, Intermediate	n	4	4n	16.3	25.3
Raster, Intermediate	n	16	16n	8.1	12.7

Table 2.1. SPIRE Spectrometer spatial sampling options

## 2.2. Spectral Resolution

A SPIRE iFTS observation building block is defined as a set of equal-length scans of the SPIRE Spectrometer Mechanism (SMEC) at a single pointing position of the Herschel Telescope and SPIRE BSM. The spectral resolution of these scans is determined by the maximum optical path difference (OPD) that the instrument can achieve by displacing the SMEC from the point of symmetry, also known as the position of zero path difference (ZPD). The spectral resolution options available to astronomical observers for the SPIRE iFTS are shown in Table 2.2.

Table 2.2. SPIRE Spectrometer spectral resolution options

Spectral Resolution	Scan Length (OPD) [cm]	Spectral Resolution [cm <sup>-1</sup> ]
Low	0.5	1.0
Medium	2.0	0.25
High	12.5	1.04

## 2.3. SPIRE iFTS Pipeline

The manner in which the basic operations relate to one another is shown in

The individual processing modules in the SPIRE spectrometer pipeline and their connection with one another are shown in Figure 2.1. Descriptions of the current implementation of these processing modules are presented in Chapter 3 and Chapter 4.

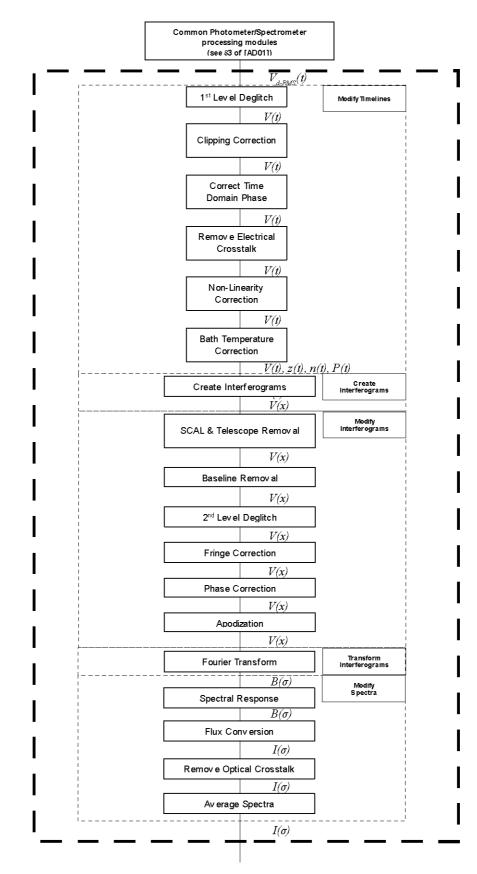


Figure 2.1. Detailed functionality of the SPIRE Spectrometer pipeline.

# **Chapter 3. SPIRE Spectrometer Building Block Pipeline**

The block diagram of the SPIRE iFTS data processing pipeline is shown in Figure 3.1. The structure of the data processing pipeline specific to the SPIRE spectrometer follows the observation building blocks. This structure was chosen as it allows the processing modules that modify the signal data of the SPIRE spectrometer detectors to take advantage of symmetries and redundancies that are present for a series of FTS scans of the same astronomical target.

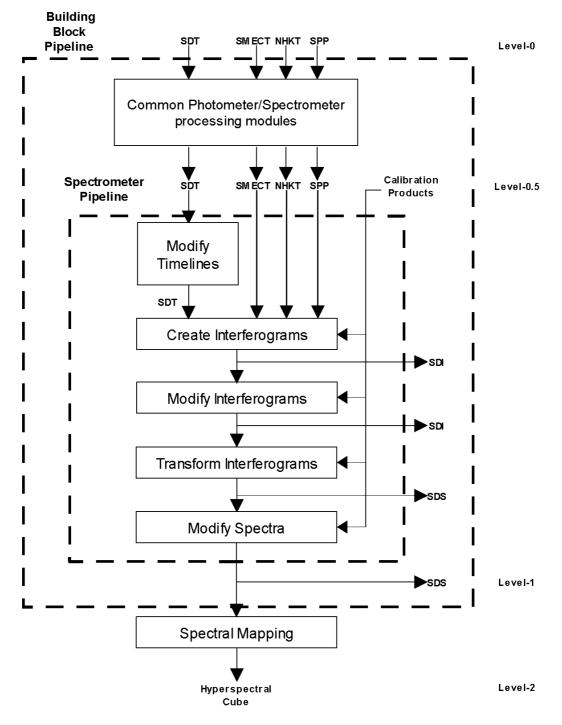


Figure 3.1. SPIRE iFTS data processing block diagram.

The data processing pipeline of the SPIRE spectrometer in two sections. The first of these sections (Chapter 3) describes the modules that make up the building block pipeline (see Figure 3.1). The processing steps that combine the building block products are then described in Chapter 4.

The SPIRE spectrometer data processing pipeline described here operates on a single observation building block at a time. The building block pipeline consists of six major processing groups (see Figure 3.1).

- 1. **Common Photometer/Spectrometer Processing modules.** The first steps of the SPIRE spectrometer and photometer pipelines are identical and are described in Section 3 of [AD01].
- 2. **Modify Timelines** The processing modules in this group perform time domain operations on the spectrometer detector samples.
- Create Interferograms The processing modules in this group merge the timelines of the spectrometer detectors and spectrometer mechanism into interferograms. The spectrometer detector samples are split into different sets, with each set defined by a single scan of the spectrometer mechanism.
- 4. **Modify Interferograms** The processing modules in this group perform operations on the spectrometer detector interferograms. These operations differ from those in the "Modify Timelines" group in that they are designed to act on spatial domain data rather than time domain data.
- 5. **Transform Interferograms** The processing modules in this group transform the interferograms into a set of spectra.
- 6. **Modify Spectra** The processing modules in this group perform operations on the spectrometer detector spectra.

## 3.1. Detector Timeline Modifications

After application of the processing steps common to both the photometer and spectrometer detectors [Section 3 of AD01], the raw samples for each one of the 66 spectrometer detectors, labeled i, will have been converted into RMS voltage timelines, V<sub>RMS-i</sub>(t). These quantities are contained in the Level 0.5 Spectrometer Detector Timeline Product (SDT).

The processing modules described in the following sections are applied to the timelines for each spectrometer detector. Each of the processing steps contained in this processing block (see Figure 3.2) accepts a Level-0.5 SDT product as input and delivers an SDT product as output.

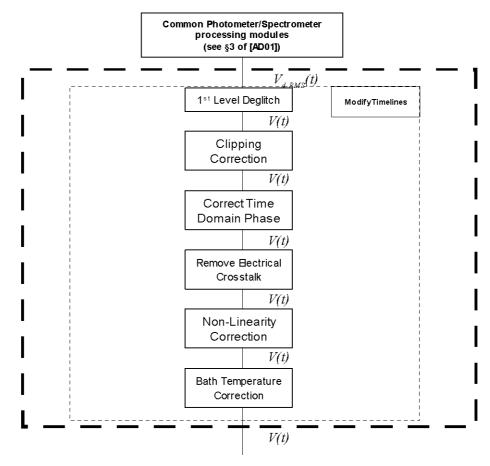


Figure 3.2. Timeline modification block of the SPIRE Spectrometer building block pipeline

## 3.1.1. First Level Deglitching

Glitches due to cosmic ray hits or other impulse-like events in the detectors will be removed using an algorithm based on a wavelet-based local regularity analysis (see Section A.1). This process is composed of two steps: the first step detects glitch signatures over the measured signal; the second step locally reconstructs a signal free of such glitch signatures.

- 1. **Glitch Identification.** Glitches are detected in the input SDT product by wavelet analysis assuming that the glitch signature is similar to the signature of a Dirac delta function
- Glitch Removal. Each glitch flagged by the preceding step is contains localized wavelet coefficients specific to the glitch. These coefficients are removed and a local, inverse wavelet transform is performed to create an SDT product that is free of glitches.

The output of this module is the deglitched voltage timeline,  $V_{1,i}(t)$  for detector i.

## 3.1.2. Removal of Electrical Crosstalk

After de-glitching, let the timeline for bolometer i be denoted as  $V_{1-i}(t)$ . This timeline might contain contributions that depend on the signals from other detectors due to either electrical or optical crosstalk. Electrical crosstalk arises after the detector and is due to capacitative or inductive coupling between the detector readout channels. Optical crosstalk occurs before the detector and is due to diffraction or aberrations in the optical system causing some of the power from an astronomical source to fall on inappropriate detectors.

Electrical crosstalk can be removed if the coupling between the detectors is known, and it is appropriate to do it at this stage.

Here it is assumed that:

- electrical crosstalk is linear, so that the effects can be characterised by a crosstalk matrix, C<sub>elec</sub>, with constant elements;
- electrical crosstalk from one detector to another involves negligible diminution of the signal in the primary detector;
- 3. there is no crosstalk between different arrays.

For a particular time-step, the vector of electrical crosstalk-corrected signals is given by  $\mathbf{V_2} = \mathbf{C_{elec}}$   $\mathbf{V_1}$ . As an illustration, with three detectors, the matrix equation would be

#### Equation 3.1.

$$\begin{bmatrix} V_{2-1} \\ V_{2-2} \\ V_{2-3} \end{bmatrix} = \begin{bmatrix} 1 & e_{21} & e_{31} \\ e_{12} & 1 & e_{32} \\ e_{13} & e_{23} & 1 \end{bmatrix} \begin{bmatrix} V_{1-1} \\ V_{1-2} \\ V_{1-3} \end{bmatrix}.$$

The electrical crosstalk matrix may be implemented as a calibration file. Determination of the elements of the electrical crosstalk matrix is a difficult problem. One possibility is to use the occasional ionizing radiation hits that the bolometers will experience. Ideally, a single event in a bolometer produces a spike only in its own output; crosstalk results in this being accompanied by lower-level responses from other detectors.

## 3.1.3. Clipping Correction

The purpose of this processing step is to correct clipped signals in the imput SDT product of the measured signals due to the limited range of the detector ADCs.

Clipped signals in the voltage timelines fo the SDT are problematic as they represent missed samples in the timeline. If left uncorrected, missed or erroneous samples can lead to further complications in particular when the timelines are converted into interferograms (Section 3.2.1).

Missed or erroneous samples can be corrected in a given SDT timeline as long as the number of consecutive missed samples SDT does not result in a violation of the Nyquist criteria. For sampled signals the Nyquist frequency defines the maximum independent frequency that is sampled. Using the nominal SPIRE spectrometer scanning parameters, the Nyquist frequency exceeds the maximum frequency of the SLW band by a factor of 6 and exceeds the maximum frequency of the SSW band by a factor of 4. As such, the sampled signals can be completely reconstructed even in the abscence of five consecutive samples for SLW and three consecutive samples for the SSW detectors.

The process by which clipped timelines are corrected is described below.

- Identify the clipped samples in the SDT timelines. Let V<sub>2-i</sub>(t<sub>k</sub>) denote those samples that
  have been flagged as being clipped, let V<sub>2-i</sub>(t<sub>j</sub>) represent all other samples, and let i represent a
  given spectrometer detector.
- 2. **Interpolate the modified SDT timeline.** A polynomial of degree eight (8) is applied to the five points before and after those identified as being clipped.
- 3. **Replace the SDT timeline.** Replace those samples that had been identified as clipped in the original detector timeline,  $V_{2-i}(t_k)$  with the results of the polynomial fit,  $V_{fit}(t_k)$ .

#### Equation 3.2.

$$V_{3-i}(t_j) = V_{2-i}(t_j)$$

Samples that were not identified as being clipped,  $V_{2-i}(t_i)$  are simply propagated to the resultant timeline,  $V_{3,i}(t)$ .

#### Equation 3.3.

$$V_{3-i}(t_k) = V''_{2-i}(t_k)$$



Further study into the number of consecutive clipped points that can be successfully corrected using this algorithm is warranted. For now, an dditional step will have the Quality Control engineer inspect any SDT that contains clipped signals to see if valid astronomical products can be derived.

#### 3.1.4. Time Domain Phase Correction

The purpose of the Time Domain Phase Correction module is to correct the detector timelines,  $V_{3-1}(t)$ , for delays induced by the filters in the readout electronics and the thermal response of the detectors themselves.

#### 3.1.4.1. Determination of the Induced Phase Shift

The SPIRE spectrometer detector chain contains a 6-pole Bessel low pass filter (LPF) as well as an additional RC LPF (see Section 3.5 of AD01) The transfer function of which is shown in Equation 3.4,

$$H_{LPF-S}(\omega_{S}) = \left[\frac{2.87}{1 + 7.85 \times 10^{-3} (j \omega_{S}) + 16.03 \times 100^{-6} (j \omega_{S})^{2}}\right] \times \left[\frac{1}{1 + 3.23 \times 10^{-3} (j \omega_{S}) + 400 \times 100^{-6} (j \omega_{S})^{2}}\right] \times \left[\frac{1}{1 + 6.26 \times 10^{-3} (j \omega_{S}) + 14.65 \times 100^{-6} (j \omega_{S})^{2}}\right] \times \left[\frac{1}{1 + 1 \times 10^{-4} (j \omega_{S})}\right]$$

In addition to the electronic LPF, the thermal behaviour of the SPIRE bolometers may be modeled as a simple RC LPF with a detector-specific time constant, τ. The frequency response of a simple RC LPF is shown in Equation 3.5,

#### Equation 3.5.

$$H_{LPF-Thermal}(\omega) = \left[\frac{\omega_{Thermal}}{(j\omega) + \omega_{Thermal}}\right]$$

These two effects may be combined into a single detector transfer function, given by Equation 3.6:

#### Equation 3.6.

$$\begin{split} H_{\textit{TOTAL}}(\omega_{\textit{S}}) = & \left[ \frac{2.87}{1 + 7.85 \times 10^{-3} (j \, \omega_{\textit{S}}) + 16.03 \times 100^{-6} (j \, \omega_{\textit{S}})^2} \right] \times \left[ \frac{1}{1 + 3.23 \times 10^{-3} (j \, \omega_{\textit{S}}) + 400 \times 100^{-6} (j \, \omega_{\textit{S}})^2} \right] \times \\ & \left[ \frac{1}{1 + 6.26 \times 10^{-3} (j \, \omega_{\textit{S}}) + 14.65 \times 100^{-6} (j \, \omega_{\textit{S}})^2} \right] \times \left[ \frac{1}{1 + 1 \times 10^{-4} (j \, \omega_{\textit{S}})} \right] \times \left[ \frac{\omega_{\textit{Thermal}}}{(j \, \omega) + \omega_{\textit{Thermal}}} \right] \end{split}$$

.

The combined response of the electronic LPFs and the thermal behaviour of the SPIRE bolometer detectors,  $H_{TOTAL}(\omega s)$ , will affect both the magnitude (Equation 3.7) and the phase (Equation 3.8) of the signals recorded by the SPIRE detectors.

#### Equation 3.7.

$$Magnitude(H_{TOTAL-i}(\boldsymbol{\omega}_S)) = |H_{TOTAL-i}(\boldsymbol{\omega}_S)|$$

#### Equation 3.8.

$$\phi_{TOTAL}(\omega_{S}) = \tan^{-1} \left[ \frac{\Im(H_{TOTAL}(\omega_{S}))}{\Re(H_{TOTAL}(\omega_{S}))} \right]$$

According to Fourier theory, a change of phase in the spectral domain corresponds to a time shift in the temporal domain. This effect is particularly problematic for the SPIRE spectrometer in scanning mode (SOF1 and SOF2 [AD05]), where the delay induced by the electronic and thermal phase can lead to errors in the interpolation of the detector signals (see Section 3.2.1).

The shift in the time domain, TDPCF, is quantified as the inverse Fourier Transform of the frequency domain phase shift as in Equation 3.8,

#### Equation 3.9.

$$TDPCF_{t-i}(t) = FT^{-1} \left[ e^{-i \phi_{TOTAL-i}(\omega_s)} \right]$$

.

#### 3.1.4.2. Correction of the Induced Shift

The input timelines  $(V_{3-1})$  are corrected by way of time convolution with the TDPCF, resulting in a set of corrected timlines,  $V_{4-1}$ .

#### Equation 3.10.

$$V_{4-i}(t) = V_{3-i}(t) \otimes TDPCF_{t-i}(t)$$

## 3.1.5. Detector Non-Linearity Correction

Even though bolometric detectors are commonly fabricated with highly linear response characteristics, the detectors of the SPIRE spectrometer will be subject to a wide dynamic range which makes a non-linear response likely. A dedicated non-linearity correction is designed to account for changes in the response of the detectors to strong signals. The form of this correction will be a function that is dependent on the amplitude of the signal itself as in Equation 3.11:

Equation 3.11.

$$V_{5-i}(t) = \int_{V_0}^{V_{4-i}} \frac{f(V)}{f(V_r)} dV$$

where f(V), the real detector responsivity,  $V_r$  is a reference voltage, and  $V_0$  is a fixed bolometer voltage. The normalized value of f(V) is derived as in Equation 3.12:

#### Equation 3.12.

$$\frac{f(V)}{f(V_r)} = K_1 + \frac{K_2}{V - K_3}$$

A calibration table will contain the values for  $V_0$ ,  $K_1$ ,  $K_2$ , and  $K_3$  for each detector. Distinct calibration tables will be used for each detector bias configuration and for each value of  $V_0$ . Initially, the quantities in these calibration tables will be based on model predictions.

## 3.1.6. Removal of correlated noise due to bath temperature fluctuations

To first order, bath temperature fluctuations will influence all detectors in an array coherently -- the temperature and corresponding output voltages will go up and down in synchronism. The bath temperature,  $T_o$ , may fluctuate due to temperature drifts within the instrument, and a set of timelines,  $V_{th-i}(t)$ , must be generated to correct for this. The most important effect of bath temperature variations for the level of fluctuations expected in SPIRE, will be the direct response of the detector output voltage. Fluctuations in  $T_o$  are expected to be much faster than a single, high-resolution scans of the spectrometer mechanism, so that this correction will be needed for such observations.

A correction timeline for each detector,  $V_{th-i}(t)$ , will be generated by way of a suitable algorithm using thermometry data (to be based on evaluation carried out on data by IPAC/JPL). This timeline is then subtracted from that detector's signal timeline,  $V_{5-i}(t)$ . In order to avoid introducing additional noise to the corrected detector timeline, the  $V_{th-i}(t)$  timeline will need to be significantly less noisy than the bolometer signals. It will therefore need to be averaged over a period of time such that it becomes a negligible fraction of the detector noise. This will require a suitable averaging period (JPL/IPAC assessment of the data indicates that a period on the order of a second or a few seconds is suitable). Thermal fluctuations on timescales shorter than this will not be tracked.

The output of this module is a set of spectrometer detector voltage timelines corrected for low-frequency thermal drifts:  $V_{5-i}(t)$  for detector i.

## 3.2. Create Interferograms

The pipeline modules listed to this point describe the operations that will be performed on the timelines in the Level 0.5 SDT product. At this point, in the SPIRE iFTS building block pipeline, three additional Level 0.5 products are required to proceed. These additional products are the Spectrometer Mechanism Timeline product (SMECT), the Nominal Housekeeping Timeline product (NHKT), and the SPIRE Pointing product (SPP) (see Figure 3.3).

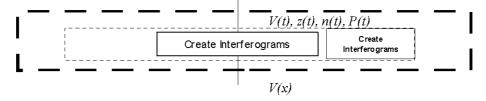


Figure 3.3. Interferogram creation block of the SPIRE Spectrometer pipeline

## 3.2.1. Interferogram Creation

A single building block of a SPIRE spectrometer observation in scanning mode consists of a series of scans of the spectrometer mechanism while the instrument is pointed at a given target. The sampling of the SPIRE spectrometer detectors and the spectrometer mechanism is decoupled; the two subsystems are sampled at different rates and at different times. In order to derive the source spectrum from the measured data, the spectrometer detector samples must be linked with the position of the SMEC in the form of interferograms. Additionally, the SMEC positions onto which the spectrometer detector signal samples are to be interpolated should be regularly-spaced in terms of optical path difference (OPD). The purpose of this step is to ensure proper transformation of the interferogram with the Discrete Fourier Transform.

The process by which interferograms are created involves two steps, each of which is described below.

- 1. **Interpolation of the SMEC timeline.** This step converts the spectrometer mechanism timeline from one that is non-uniform in position to one that is uniform in position.
  - a. **Establish a common OPD position vector.** This step creates a common vector of OPD positions that will be the basis of the interferograms for all of the spectrometer detectors and for all of the scans in the observation. This common position vector will contain samples that are uniformly-spaced in terms of OPD position as well as a sample at the position of zero-path-difference (ZPD).

The step size of the common OPD vector is chosen is such a way as to match the sampling rate of the spectrometer detector signal samples. For an SDT sampling rate s [Hz] and a SMEC scanning speed  $v_{SMEC}$  [cm/s MPD], the position step size,  $\delta$ MPD in units of cm; is given by:

#### Equation 3.13.

$$\delta MPD = v_{SMEC}^{} \, / \, s$$

This step is then converted such that it is in terms of OPD by the following relation

#### Equation 3.14.

$$\delta OPD = FLOOR[4\delta MPD]$$

where FLOOR[] denotes that the step size is rounded down to the nearest integer in units of  $\mu m$  OPD and the factor of four is the nominal conversion between MPD and OPD for a Mach-Zehnder FTS. Using the nominal SPIRE spectrometer settings -- s=80Hz,  $v_{SMEC}^{}=\!0.05cm/s$  -- this results in an OPD step size of 25  $\mu m$ .

b. Map the common OPD position vector to a SMEC position vector for each spectrometer detector. This step maps, for each spectrometer detector, the common OPD positions established in the preceding positions in units of mechanical path difference. This step involves: a scaling factor, f, that takes into account the step size for a Mach-Zehnder FTS; and a shifting factor, ZPD, which establishes the position of zero optical path difference. Since these quantities are unique to each spectrometer detector, i, this mapping is performed on a detector-by-detector basis and is shown in Equation 3.15.

#### Equation 3.15.

$$MPD_i = \frac{OPD}{f_i} + ZPD_i$$

c. Parse the measured SMEC timeline into discrete scans. This step splits the full SMEC

timeline ( $z(t_{SMEC})$ ) from the input SMECT product into a series of discrete timelines,  $z_n(t_{SMEC})$ . Each of the discrete timelines,  $z_n(t_{SMEC})$ , represents one spectrometer scan. The delineation of the SMEC timeline is accomplished by comparing consecutive SMEC position samples and finding those samples where the motion of mirror mechanism changed direction.

d. Interpolate the measured SMEC timelines onto the mapped SMEC timelines. The next step is to determine, on a detector-by-detector and scan-by-scan basis, the times when the spectrometer mechanism reached the mapped SMEC positions. Since, for each detector, there is a 1:1 relationship between the mapped SMEC positions and the regularly-spaced OPD positions, this step effectively determines the times when the SMEC reached the regularly-spaced OPD positions for each detector.

#### Equation 3.16.

$$z_n(t_{SMEC}) \rightarrow MPD_{n-i}(t_{MPD-i})$$

- Merge the spectrometer detector and the mapped SMEC timelines. This step combines the signal samples from the signal timeline of a given spectrometer detector (V<sub>5-i</sub>(t<sub>i</sub>)) with the mapped SMEC timelines.
  - a. **Interpolation of the spectrometer detector timelines.** The spectrometer detector signal samples are mapped onto the times corresponding to the regular MPD (t<sub>MPD-i</sub>) positions by way of interpolation. Since there is a 1:1 relationship between these time samples, tMPD-i, and the regular MPD positions, MPD, this interpolation effectively maps, for each detector, the signal samples to the regularly-spaced MPD positions. Moreover, since there is a 1:1 relationship between the regular MPD positions for each detector and the common OPD positions, this step accomplishes the mapping of the signal samples for each detector to the common OPD positions, which is the resultant interferogram that is desired.

#### Equation 3.17.

$$V_{5-i}(t_i) \rightarrow V_{6-i}(t_{MPD-i}) \rightarrow V_{6-i}(t_{OPD}) \rightarrow V_{6-i}(OPD) \equiv V_{6-i}(x)$$

The process outlined above is repeated for all spectrometer detectors for each scan of the observation building block. The resultant interferograms are then combined into a single Spectrometer Detector Interferogram (SDI) product. In addition, the mean value of the pointing, P(t), as derived from the input SPIRE Pointing product (SPP) for the observation building block is assigned to the output SDI product.

## 3.3. Modify Interferograms

The pipeline modules described in this section perform operations on the interferograms created in the previous step. Each of the processing steps contained in this processing block accepts an SDI product as input and delivers an SDI product as output (see Figure 3.4).

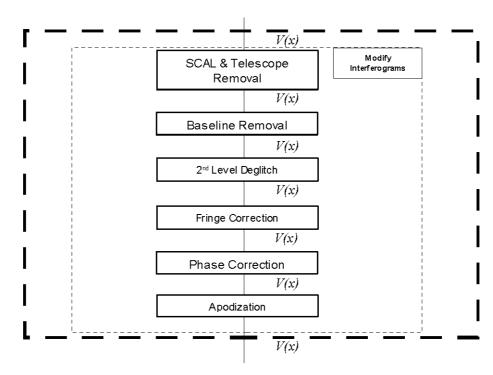


Figure 3.4. Interferogram modification block of the SPIRE Spectrometer pipeline

## 3.3.1. SCAL and Telescope Correction

The equation for the total intensity of the radiation incident upon the spectrometer detectors shows that, in addition to radiation from the astronomical source, the detectors record a modulated signal from the Herschel Telescope and from each of the components of the spectrometer calibrator (SCAL). This processing step removes these components from the measured interferogram.

#### Equation 3.18.

$$V_{6-i}(x) = \left(V_{6-SOLICe-i}(x) + V_{6-Telescope-i}(x) + V_{6-SCAL-i}(x) + V_{6-SCAL2-i}(x) + V_{6-SCAL4-i}(x)\right)$$

The method employed in the simple pipeline to correct for the Herschel Telescope and the SCAL components is to subtract from the measured interferogram  $(V_{6-i}(x))$  a interferogram derived from a calibration observation wherein the Telescope is pointed at blank sky  $(V_{6-ref-i}(x))$ . This calibration observation will also have both SCAL2 and SCAL4 set to the same temperatures as was the case for the on-source observation.

#### Equation 3.19.

$$V_{6-ref-i}(x) = \left(V_{6-Telescope-ref-i}(x) + V_{6-SCAL-ref-i}(x) + V_{6-SCAL2-ref-i}(x) + V_{6-SCAL4-ref-i}(x)\right) = \left(V_{6-Telescope-ref-i}(x) + V_{6-SCAL4-ref-i}(x) + V_{6-SCAL4-ref-i}(x)\right) = \left(V_{6-Telescope-ref-i}(x) + V_{6-SCAL4-ref-i}(x) + V_{6-SCAL4-ref-i}(x)\right) = \left(V_{6-Telescope-ref-i}(x) + V_{6-Telescope-ref-i}(x)\right) = \left(V_{6-Telescope-ref-i}(x) + V_{6-Telescope-ref-i}(x)\right)$$

#### Equation 3.20.

$$V_{7-i}(x) = V_{6-i}(x) - V_{6-ref-i}(x)$$

In the model-based pipeline, removal of the Telescope and SCAL contributions is performed by

subtraction of a model their contributions derived from the measured temperatures of each element and the measured transmission through the spectrometer for each emitting element. This method has the advantage of not requiring a blank-sky calibration observation though the precision of such a method cannot be evaluated until flight conditions are observed.

The result of the Telescope and SCAL correction step will be a set of interferograms for each spectrometer detector  $(V_{7-i}(x))$ ; these interferograms are stored in an SDI product. The principal component of the resultant interferograms is radiation from the astronomical source.

## 3.3.2. Interferogram Baseline Correction

According to the equations presented in Section A.2, the overall intensity incident on the SPIRE spectromter detectors can be separated into two components: a component that is constant as a function of OPD; and a component that is modulated as a function of OPD. As the offset term does not contain any spectral information, it may be removed without affecting the source spectrum.

On a detector-by-detector and scan-by-scan basis, the baseline correction algorithm evaluates and removes the offset portion of the derived interferogram  $(V_{7,i}(x))$ . The preferred manner to evaluate the offset is to fit a fourth-order polynomial to the measured interferogram.

#### Equation 3.21.

$$V_{Baseline-i}(x) = a_i + b_i x + c_i x^2 + d_i x^3 + e_i x^4$$

Once evaluated, the fitted function is removed from the measured interferogram by subtraction.

#### Equation 3.22.

$$V_{8-i}(x) = V_{7-i}(x) - V_{Baseline-i}(x)$$

## 3.3.3. Second Level Deglitching

Localized artifacts in the interferograms, glitches, pose a serious problem for Fourier Transform Spectrometer observations. As such, a glitch that affects as few as one interferogram sample can adversely affect each and every spectral component. Glitches in an interferogram must therefore be identified and removed prior to transformation in order to avoid unwanted spectral artifacts.

Glitches are identified for each spectrometer detector, i, by comparing, on a OPD-position-by-OPD-position basis (i.e. each  $x_k$ ), the samples from one scan, j, to those from all other scans in the same observation (scan number n, where n # j). The samples that deviate more than a prescribed amount from the median are flagged as glitches.

The samples that are identified as glitches are then replaced. For a glitch at a given position for a given spectrometer detector, the value of the replacement sample is determined by the average of the non-glitch samples from the other observed interferograms at that position.

#### Equation 3.23.

$$V_{j-8-i}(x_k) = \frac{1}{N_{scans} - 1} \sum_{n=i, n \neq j}^{N_{scans}} V_{n-8-i}(x_k)$$



The two steps of the interferogram deglitching module rely on a statistical analysis of the measured interferograms. As such, a minimum number of six interferograms per building block will be required so that these statistics will be meaningful.

## 3.3.4. Channel Fringe Correction

The effect of channel fringes on spectrometer data is similar to that of glitches (Section 3.3.3). If left uncorrected the channel fringes will contaminate the measured spectrum. Currently, three different algorithms are being evaluated as possible methods to correct for channel fringes. These are:

Two other methods of fringe correction are under consideration. These methods are:

1. **Apodization.** The application of an apodization function (Section 3.3.6) is currently the baseline method for fringe correction. While apodization is effective at removing the spectral artifacts due to the channel fringes, its application results in a reduction of the observed spectral resolution. Given that the fringe features appear at the extreme high-resolution OPD end for the SLW array and at the extreme medium-resolution end for the SSW array, however, the reduced resolution is not expected to be significant for those observing modes.

With apodization (Section 3.3.6) chosen as the preferred method of fringe correction, there is no need for a separate fringe correction processing step.

- 2. **Interferogram Truncation.** This method of channel fringe removal involves truncating the interferogram prior to the channel fringe region. The drawback to this method is similar to that for apodization; reduced spectral resolution.
- 3. **Iterative Subtraction.** This method of channel fringe correction is performed by removing successive copies of the interferogram in the region near ZPD from the wing portion of the interferogram.

### 3.3.5. Phase Correction

The symmetry of a Fourier Transform spectrometer theoretically implies that interferograms recorded by the spectrometer will exhibit even symmetry. Since the spectrum of an evenly symmetric interferogram contains only real components, it is therefore expected that the phase should be zero for all spectral components.

The presence of dispersive elements and the possibility that the position of zero path difference not being sampled can, however, result in a interferogram whose *signal* samples are not symmetric about ZPD. The spectrum calculated from this sort of asymmetric interferogram will contain both real and imaginary components and therefore a non-zero phase.

The phase correction module is separated into two components: the first step identifies whether any phase is present in the measured interferogram; the second step removes this phase.

1. **Phase Identification.** The first step of the phase correction process is to identify whether the measured interferograms contain any non-zero phase. In order to make this determination, the spectrum of the double-sided (see Section A.3.1) portion is computed for each interferogram (Equation 3.24)

Equation 3.24.

$$B_{10-i-DS}(\sigma) = FT \left[ V_{10-i}(x|_{-L}^{L}) \right] = \int_{-L}^{L} V_{10-i}(x) e^{-i2\pi\sigma x} dx$$

where L represents the extent of the interferogram about the ZPD position. The phase of the computed spectrum may be evaluated for each spectral component or wavenumber as in Equation 3.25.

#### Equation 3.25.

$$\phi_{i-DS}(\sigma) = \arctan\left(\frac{\Im(B_{10-i-DS}(\sigma))}{\Re(B_{10-i-DS}(\sigma))}\right)$$

2. **Phase Removal.** The phase in the measured interferograms having been identified, the next step in the process is phase removal. A fourth-order polynomial fit to the measured in-band phase (see Equation 3.26)) rather than the measured phase itself is used in this process. The basis for using the fitted phase rather than the calculated phase is that, by doing so, the noise associated with the imaginary portion of the computed spectrum remains in the imaginary domain. If the phase is stable and the noise is due primarily to random sources, the usage of a fitting function can lead to an increase in the resultant signal-to-noise ratio by a factor of √2.

#### Equation 3.26.

$$\phi_{fit-i}(\sigma) = a_i + b_i \sigma + c_i \sigma^2 + d_i \sigma^3 + e_i \sigma^4 \Big|_{\sigma_{LOW}}^{\sigma_{HIGH}}$$

A phase correction function (PCF) is then derived from the fitted phase for each interferogram as in Equation 3.27).

#### Equation 3.27.

$$PCF_{i}(\boldsymbol{\sigma}) = e^{-i\phi_{fit-i}(\boldsymbol{\sigma})}$$

The derived PCFs are then applied to spectra computed from each of the interferograms in the input SDI product by way of multiplication (Equation 3.28).

#### Equation 3.28.

$$B_{11-i}(\sigma) = B_{10-i}(\sigma) \times PCF_i(\sigma)$$
  
=  $B_{10-i}(\sigma) \times e^{-i\phi_{ft-i}(\sigma)}$ 

If the observing mode is low- or medium-resolution, the above represents the final step in the phase correction process. High-resolution observations require an extra step. Phase correction of high-resolution interferograms, proceeds in the interferogram (spatial) domain wherein a convolution of the measured interferogram and the inverse FT of the PCF is performed (see Equation 3.29).

#### Equation 3.29.

$$\begin{split} \boldsymbol{V}_{11-i}(x) &= \boldsymbol{V}_{10-i}(x) \otimes FT^{-1} \big[ PCF_{i}(\sigma) \big] \\ &= \boldsymbol{V}_{10-i}(x) \otimes FT^{-1} \big[ e^{-i\phi_{\beta t-i}(\sigma)} \big] \\ &= \boldsymbol{V}_{10-i}(x) \times \sum_{x=-l}^{l} \big( FT^{-1} \big[ e^{-i\phi_{\beta t-i}(\sigma)} \big] \big)(x) \end{split}$$

where I represents the extent of convolution kernel, i.e. the inverse transform of the PCF.

## 3.3.6. Apodization

The natural instrument line shape (ILS) for a Fourier Transform spectrometer is a cardinal sine, or Sinc function. If the source signal contains features at or near the resolution of the spectrometer, the ILS can introduce secondary maxima in the spectra. The apodization functions available within this module may be used to reduce these secondary maxima at the cost of reducing the resolution of the resultant spectrum. The apodization module in the SPIRE spectrometer data processing pipeline offers a number of apodizing functions that to allow for an optimal trade-off between reduction in the secondary maxima and reduced resolution [RD03].

Apodization is performed by multiplying the input interferograms  $(V_{n-11-i}(x))$ , on a detector-by-detector and on a scan-by-scan basis with a tapering or apodizing function.

Equation 3.30.

$$V_{12-i}(x) = V_{11-i}(x) \times Apod_i(x)$$

## 3.4. Transform Interferograms

At this point in the building block pipeline, the operations that are best performed in the interferogram domain have been implemented. From this point on, further processing can take place in the spectral domain. As such, this presents the opportunity to transform the interferograms for each detector,  $V_{q,i}(x)$ , to the spectral domain. The section describes the process by which the interferograms contained in the Level 1 SDI product created by the preceding steps are transformed to spectra that will be contained in a Level 0.5 Spectrometer Detector Spectrum (SDS) product (see Figure 3.5).

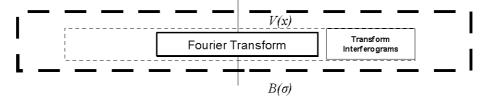


Figure 3.5. Interferogram transformation block of the SPIRE Spectrometer pipeline

### 3.4.1. Fourier Transform

The purpose of the Fourier Transform module is to transform the set of interferograms from a SPIRE spectrometer observation into a set of spectra. This processing module is capable of transforming both double-sided and single-sided interferograms (see Appendix A for the definition of double-sided and single-sided interferograms).

**Double-sided Transform.** For the double-sided transform, each interferogram in the SDI is examined and only the double-sided portion of the interferogram is used to compute the resultant spec-

trum. The resultant spectra will contain both real and imaginary components.

#### Equation 3.31.

$$B_{12-i}(\sigma) = FT \left[ V_{12-i}(x) \right]_{-L}^{L} = \int_{-L}^{L} V_{12-i}(x) e^{-i2\pi\sigma x} dx$$

In this case, the discrete fourier transform that is used to compute the spectral components takes the form shown in Equation 3.32.

#### Equation 3.32.

$$B_{12-i}(k) = \sum_{n=0}^{N-1} V_{12-i}(n) e^{-i\frac{2\pi kn}{N}}$$

**Single-sided Transform.** In the case of the single-sided transform, only those interferogram samples to one side of the position of zero path difference are considered. The spectra that result from the single-sided transform therefore contain only real components.

#### Equation 3.33.

$$B_{12-i}(\sigma) = FT \left[ V_{12-i}(x) \Big|_{0}^{L} \right] = \int_{0}^{L} V_{12-i}(x) e^{-i2\pi\sigma x} dx$$

The discrete fourier transform that is used to compute the spectral components for single-sided interferograms takes the form shown in Equation 3.34.

#### Equation 3.34.

$$B_{12-i}(k) = \sum_{n=0}^{N-1} V_{12-i}(n) \cos \frac{2\pi kn}{N}$$

Wavenumber Grid. For both the single-sided and double-sided transforms the wavenumber grid onto which the spectrum is registered is calculated based on the interferogram sampling rate ( $\Delta$ OPD) and on the maximum OPD displacement from the position of ZPD, L.

The Nyquist frequency ( $\sigma_{\text{Nyquist}}$ ), the maximum independent frequency in the output spectrum, is given by:

#### Equation 3.35.

$$\sigma_{Nyquist} = \frac{1}{2\Delta OPD}$$

The spacing between independent spectral samples ( $\Delta \sigma$ ) is given by:

#### Equation 3.36.

$$\Delta \sigma = \frac{1}{2L}$$

The spacing between spectral samples can be modified by padding the interferogram with zeroes. This procedure does not add any information to the spectrum but allows for an easier comparison between observations. In this case, a zero-padded interferogram  $(V_{12-ZP-i})$  is given by:

#### Equation 3.37.

$$V_{12-ZP-i}(x) \! = \! V_{12-i}(x)|_0^L$$
 ,  $0|_0^{L < x \le L_{ZP}}$ 

The corresponding spectral sampling interval is given by:

#### Equation 3.38.

$$\Delta \sigma_{ZP} = \frac{1}{2L_{ZP}}$$

and the resultant spectrum of the zero-padded interferogram is given by:

#### Equation 3.39.

$$B_{12-ZP-i}(k) = \sum_{n=0}^{N_{ZP}-1} V_{12-ZP-i}(n) e^{-i\frac{2\pi kn}{N_{ZP}}}$$

The scan lengths and resultant spectral sampling intervals for the three distinct spectral resolutions from Section 6.6 of [AD03] are given in Table 3.1.

Table 3.1. Interferogram Padding

Spectral Resolution [AD03]	Sampling Interval (OPD) [µm]	Nyquist Wavenum- ber [cm <sup>-1</sup> ]	Padded Scan Length (OPD) [cm]	Spectral Sampling Interval [cm <sup>-1</sup> ]
Low	25	200	2.0	0.25
Medium	25	200	10.0	0.05
High	25	200	50.0	0.01

This processing step will create a Level-1 Spectrometer Detector Spectrum (SDS) product that will be available to observers.

## 3.5. Modify Spectra

The pipeline modules that follow in this section describe the operations that will be performed on the Level 0.5 SDS products that were created in the preceding step. The end result of these spectral modifying processing steps will be a Level 1 SDS product that contains a single, flux-calibrated, averaged spectrum for each spectrometer detector,  $I_i(\sigma)$ . The spectral modification creation block is shown in Figure 3.6.

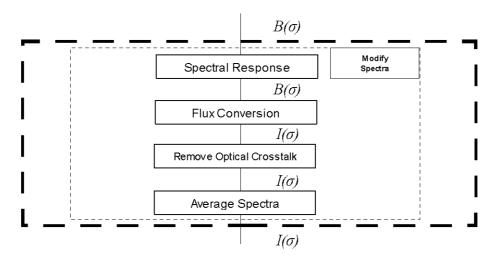


Figure 3.6. Spectral modification block of the SPIRE Spectrometer pipeline

## 3.5.1. Spectral Response Correction

This module will remove from each measured spectrum for each detector in the input SDS product the relative spectral response function (RSRF) for that particular detector. The correction that is to be applied is given in Equation 3.40.

Equation 3.40.

$$B_{13-i}(\boldsymbol{\sigma}) = \frac{B_{12-i}(\boldsymbol{\sigma})}{RSRF_i(\boldsymbol{\sigma})}$$

The RSRF curves for each detector (RSRF $_i(\sigma)$ ) represent the relative transmission of the SPIRE instrument from the Telescope port to a detector, i. The procedure by which these curves will be derived is given in [RD01].

### 3.5.2. Flux Conversion

The flux conversion module translates each of the measured spectra ( $I_{n-12-i}$  in the input SDS product from voltage quantities with units of [Volts/(cm<sup>-1</sup>)] to an optical power quantities with units of [either Watts/m<sup>2</sup>/(cm<sup>-1</sup>) or Janskys]. This conversion occurs on a wavenumber-by-wavenumber basis as in Equation 3.41.

Equation 3.41.

$$I_{14-i}(\boldsymbol{\sigma}) = B_{13-i}(\boldsymbol{\sigma}) \times f_i(\boldsymbol{\sigma})$$

The exact manner by which the conversion curves,  $f_i(\sigma)$ , will be derived is still TBD but the current baseline is to perform a calibration observation of a source with a known flux. The spectrum derived for each spectrometer detector  $B_{13,i}(\sigma)$  will then be used as the conversion curve for this module.

## 3.5.3. Removal of Optical Crosstalk

Optical crosstalk is here defined as power from the astronomical sky that should be incident on one detector actually falling on another. It is important to note that in the case of SPIRE, neighboring de-

tectors are separated by approximately twice the of the incident beam, therefore even if a source is on-axis for a given detector, a small fraction of the source power will be incident on the neighboring detectors due to telescope diffraction. Non-neighbouring detectors are sufficiently far apart that they should not pick up any power from an on-axis source.

Optical crosstalk will be characterised by a crosstalk matrix,  $C_{opt}$ , analogous to the electrical crosstalk matrix described in Section 3.1.2. Let  $\mathbf{I_{14}}$  be the input vector of spectral flux densities.

The vector of optical crosstalk-corrected spectral flux densities is then given by  $I_{15} = C_{opt} I_{14}$ 

As an illustration, if there are three detectors, the matrix equation would be

#### Equation 3.42.

$$\begin{vmatrix} I_{15-1} \\ I_{15-2} \\ I_{15-3} \end{vmatrix} = \begin{vmatrix} o_{11} & o_{21} & o_{31} \\ o_{12} & o_{22} & o_{32} \\ o_{13} & o_{23} & o_{33} \end{vmatrix} \begin{vmatrix} I_{14-1} \\ I_{14-2} \\ I_{14-3} \end{vmatrix}$$

Unlike the case of electrical crosstalk (Section 3.1.2), the diagonal elements are not necessarily equal to unity since optical crosstalk involves loss of power from the primary detector.

The optical crosstalk matrix may be implemented as a calibration file. The method by which the components of the optical crosstalk matrix,  $C_{opt}$ , is TBD.



Note In the absence of optical crosstalk, or if the crosstalk correction is to be omitted, then the non-diagonal coefficients of  $\mathbf{C}_{opt}$  are set to zero and the diagonal coefficients are set to unity.

## 3.5.4. Spectral Averaging

This module also computes, on a wavenumber-by-wavenumber basis for each spectrometer detector, the average of the spectral intensities across all scans (see Equation 3.43).

#### Equation 3.43.

$$\overline{I_{16-i}(\boldsymbol{\sigma}_{k})} = \frac{1}{N_{scans}} \sum_{n=i}^{N_{scans}} I_{n-15-i}(\boldsymbol{\sigma}_{k})$$

This module also computes, on a wavenumber-by-wavenumber basis for each spectrometer detector, the uncertainty in the spectral average. The uncertainty is calculated as the standard deviation of the spectral components as in Equation 3.44.

#### Equation 3.44.

$$\delta I_{16-i}(\sigma_{k}) = \sqrt{\frac{1}{N_{scans}} - 1} \sum_{n=1}^{N_{scans}} \left( I_{n-15-i}(\sigma_{k}) - \overline{I_{n-15-i}(\sigma_{k})} \right)^{2}$$

# Chapter 4. SPIRE iFTS Spectral Mapping

The pipeline modules that follow in this section describe the operations on the Level-1 SDS products created in the preceding step. The end result of these spectral modifying processing steps will be a Level-2 Spectrum Cube product.

## 4.1. SPIRE iFTS Spatial Regridding

The SPIRE iFTS building block pipeline produces one spectrum per detector. The spatial distribution of the spectra in the astronomical region of interest from a single pointing follows approximately a honeycomb pattern as per the design of the detector arrays (Figure 4.1).

For an observation performed at intermediate or full spatial sampling (Figure 4.2, Figure 4.3), the set of Level 1 SDS products is interpolated onto a hyperspectral data cube that is equidistantly sampled in the two spatial dimensions while leaving the equidistant grid along the spectral dimension unchanged. This operation will not be applied in the sparse spatial sampling mode (Figure 4.1) as the spatial sampling in that mode will not meet the Nyquist criteria.

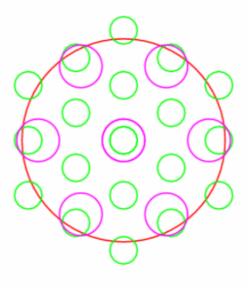


Figure 4.1. Astronomical footprint of the SPIRE detector arrays; sparse spatial sampling mode. [AD03]

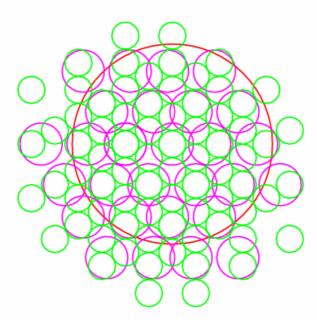


Figure 4.2. Astronomical footprint of the SPIRE detector arrays; intermediate spatial sampling mode. [AD03]

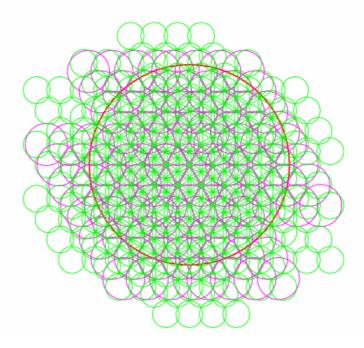


Figure 4.3. Astronomical footprint of the SPIRE detector arrays; full spatial sampling mode. [AD03]

An algorithm for the interpolation of spectral data collected at non-uniformly sampled locations has been identified and a normalized convolution algorithm has been implemented [RD05]. The algorithm iterates along the spectral dimension and evaluates a two-dimensional convolution of the measurements at given sky positions with a separable two-dimensional kernel describing the field of view of the detectors. Ground-based measurements have shown that the of the beam of the SPIRE

spectrometer detectors vary in a non-linear fashion with frequency between 15.5 and 17.5 arcsec for the SSW and between 31 and 41 arcsec for the SLW band [RD06]. Th interpolation algorithm is well set up to take such a frequency-dependent beam size into account. It does, however, assume that the beam sizes of all detectors are identical. The suitability of this procedure remains to be verified.

## Appendix A. Appendix

## A.1. First Level Deglitching Description

 Glitch Identification. Glitch signatures are detected by performing a local regularity analysis (Holderian analysis) over the wavelet transform modulus maxima lines (WTMML) of the signal.

Let H be the Holder exponent, s the scale of decomposition,  $X_i(s)$  the time (or OPD) domain coordinate of the maxima line for the scale s, then when the scale s goes to zero the corresponding wavelet coefficient,  $W(X_i(s),s)$ , is given by:

#### Equation A.1.

 $W(X_i(s), s) \leq Cs^H$ 

where C is a real constant.

The scale of decomposition, s, may be expressed over a logarithmic scale as:

#### Equation A.2.

$$s=2^{\rm o}\;2^{v/nV}$$

where positive integers o, nV, and v (with v < nV) are respectively called octave, number of voices, and voice of the decomposition  $^1$ , respectively.

On each maxima line, the regularity degree of the signal is estimated by computing the slope of the linear regression over the set of points  $(\log_2(|W|), \log_2(s))$  over the range of scales [scaleMin, scaleMax]. If the relation is linear, i.e. if the square of its correlation coefficient C is greater than the threshold coefficient *thresholdCorr* then the Holder exponent C can be estimated by the measure of the slope of the relation. Glitches are detected as they are similar to dirac-like signatures and show a Holder exponent (i.e. regularity degree) close to -1, ie in a range [thresholdHolder, hMin] centered over -1.

Noise can generate false detections (it can be shown that the Holder exponent of a gaussian noise has a value (in mean) of 0.5). In order to minimize the likelihood of these false positives, contraints are applied to the wavelet coefficients. By considering a gaussian noise of standard deviation  $\sigma$ , it can be shown that at the lowest scale of decomposition, the following threshold:

#### Equation A.3.

 $|W| \ll \sigma \sqrt{(2 \ln N)}$ 

where N is the size of the signal.

The noise standard deviation  $\sigma$  on the signal can be estimated using the Donoho estimator; at the lowest scale,  $\sigma = 0.6745 \times \text{med} |W|$ 

For each maxima line, if the value of the wavelet coefficient for the first scale value is greater than the previous threshold an estimate is made of the regularity degree.

**Glitch Removal.** Each glitch flagged by the preceding step is characterized by a Holder exponent H and by a maxima line X giving for each scale s the location of the maximum of the modulus of the wavelet coefficient X(s). For a glitch signature (the Holder exponent H ~ -1), it can be shown that the wavelet coefficients  $W_{\sigma}$  are given by:

<sup>&</sup>lt;sup>1</sup> C.Ordenovic, C. Surace, B. Torresani, A. Llebaria, "Glitches detection and signal reconstruction using Holder and wavelet analysis.", ADAIV preprint, 5 March 2007.

#### Equation A.4.

 $W_g = \psi((b-X(s))/s)$ 

 $\psi$  being the wavelet function.

The glitch coefficients,  $W_g$ , are then subtracted from the wavelet coefficients,  $W_g$ , and the signal is locally reconstructed by performing a wavelet transform over the corrected wavelet coefficients.

The parameters that follow are optional and have been optimzed for the SPIRE spectrometer detectors. SPIRE PFM1 data that, by visual inspection, contained 29 glitches was used as a basis for this optimization.

- **scaleMin, scaleMax**: The scale range used for the linear regression. Optimal values are scaleMin = 2 and scaleMax = 8.
- **thresholdHolder and H**<sub>min</sub>: The Holder exponent range used to select a glitch. Optimal values are thresholdHolder = -0.6,  $H_{min} = -1.3$ .
- **thresholdCorr**: The square threshold correlation that defines linear behaviour. The optimal value is thresholdCorr = 0.985.
- voices: The number of voices used for the scale decomposition, he optimal value is voices = 5.

## A.2. Radiation Incident on the SPIRE Spectrometer Detectors

The radiation path through the SPIRE spectrometer is illustrated for one case in Figure A.1.

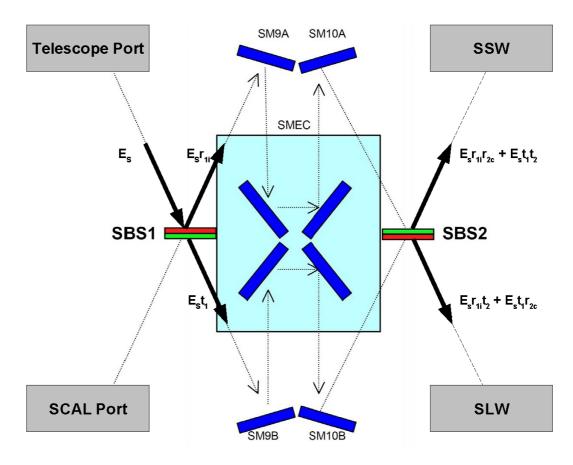


Figure A.1. Radiation from an astronomical source through the SPIRE spectrometer

As shown in Figure A.1, the first beamsplitter (SBS1) divides the incoming electric field ( $E_S$ ) into two components ( $E_S r_{1c}$  and  $E_S t_1$ ). These two components pass through the interferometer and then are split further at the second beamsplitter (SBS2). The upper beam from Figure A.1 then passes to the SSW detectors while the lower beam passes to the SLW detectors. The electric fields incident on the SSW and SLW detectors are given by the following equations:

#### Equation A.5.

$$E_{S-SSW}(x,\sigma) = E_{S_0}(\sigma) \left[ r_{1_i} r_{2_o} e^{-i2\pi(\sigma x_1 - vt)} + t_1 t_2 e^{-i2\pi(\sigma x_2 - vt)} \right]$$

#### Equation A.6.

$$E_{S-SLW}(x,\sigma) = E_{S_0}(\sigma) \left[ r_{1_i} t_2 e^{-i2\pi(\sigma x_1 - \nu t)} + t_1 r_{2_i} e^{-i2\pi(\sigma x_2 - \nu t)} \right]$$

At the detectors, the intensity recorded is the time-average of the square of the incident electric field. Using the SSW detectors for illustration, the measured intensity for radiation from an astronomical source at the detectors is given by the following:

#### Equation A.7.

$$I_{S}(x,\sigma) = \frac{c \epsilon_{0}}{2} E_{S}^{*}(x,\sigma) E_{S}(x,\sigma)$$

where:

#### Equation A.8.

$$E_{\scriptscriptstyle S}^{\;*}(x\,,\sigma)E_{\scriptscriptstyle S}(x\,,\sigma)=E_{\scriptscriptstyle S_0}^{*}(\sigma)\Big[r_{\scriptscriptstyle 1_i}r_{\scriptscriptstyle 2_c}\mathrm{e}^{\imath 2\pi\,(\sigma\,x_1)}+t_1t_2\mathrm{e}^{\imath 2\pi\,(\sigma\,x_2)}\Big]\times E_{\scriptscriptstyle S_0}(\sigma)\Big[r_{\scriptscriptstyle 1_i}r_{\scriptscriptstyle 2_c}\mathrm{e}^{-\imath 2\,\pi(\sigma\,x_1)}+t_1t_2\mathrm{e}^{-\imath 2\,\pi(\sigma\,x_2)}\Big]$$

#### Equation A.9.

$$E_{S}^{*}(x,\sigma)E_{S}(x,\sigma)=E_{S_{0}}^{2}(\sigma)\left[\left(r_{1_{i}}r_{2_{c}}\right)^{2}+\left(t_{1}t_{2}\right)^{2}+2r_{1_{i}}r_{2_{c}}t_{1}t_{2}\cos 2\pi\sigma\left(x_{1}-x_{2}\right)\right]$$

Combining the above results in the following equations for the measured intensity at the SSW and SLW detectors for radiation from an astronomical source:

#### Equation A.10.

$$\begin{split} I_{SSW}(x) &= \int\limits_{0}^{\infty} I_{SSW}(x,\sigma) \, d\,\sigma \\ &= \int\limits_{0}^{\infty} E_{0}^{2}(\sigma) \Big[ \big( r_{1_{i}} r_{2_{e}} \big)^{2} + \big( t_{1} t_{2} \big)^{2} + 2 \, r_{1_{i}} r_{2_{e}} t_{1} t_{2} \cos{(2 \, \pi \, \sigma \, x)} \Big] d\,\sigma \\ &= I_{SSW}(0) \Big[ \big( r_{1_{i}} r_{2_{e}} \big)^{2} + \big( t_{1} t_{2} \big)^{2} \Big] + 2 \int\limits_{0}^{\infty} \Big[ r_{1_{i}} r_{2_{e}} t_{1} t_{2} \Big] B(\sigma) \cos{(2 \, \pi \, \sigma \, x)} \, d\,\sigma \\ &= I_{SSW-Offset} + I_{SSW-Modulated}(x) \end{split}$$

#### **Equation A.11.**

$$\begin{split} I_{\mathit{SLW}}(x) &= \int\limits_{0}^{\infty} I_{\mathit{SLW}}(x,\sigma) \, d\,\sigma \\ &= \int\limits_{0}^{\infty} E_{0}^{2}(\sigma) \Big[ \big( r_{1_{i}} t_{2} \big)^{2} + \big( t_{1} r_{2_{i}} \big)^{2} - 2 \, r_{1_{i}} r_{2_{i}} t_{1} t_{2} \cos{(2 \, \pi \, \sigma \, x)} \Big] \, d\,\sigma \\ &= \Big[ \big( r_{1_{i}} t_{2} \big)^{2} + \big( t_{1} r_{2_{i}} \big)^{2} \Big] I_{\mathit{SSW}}(0) - 2 \int\limits_{0}^{\infty} \Big[ r_{1_{i}} r_{2_{i}} t_{1} t_{2} \Big] B(\sigma) \cos{(2 \, \pi \, \sigma \, x)} \, d\,\sigma \\ &= I_{\mathit{SLW-Offset}} + I_{\mathit{SLW-Modulated}}(x) \end{split}$$

In addition to the astronomical source, radiation from the Herschel telescope and the three components of SCAL (SCAL2, SCAL4, and SCAL) is incident on the SPIRE spectrometer detectors. For the telescope radiation, its path through the SPIRE spectrometer is the same as that for the astronomical source. The path for the SCAL emitters is slightly different (see Figure A.1). The equations for the radiation incident on the SSW and SLW detectors are given by the following:

#### **Equation A.12.**

$$\begin{split} I_{SSW}(x) &= \int\limits_{0}^{\infty} I_{SSW}(x,\sigma) \, d\sigma \\ &= \int\limits_{0}^{\infty} E_{0}^{2}(\sigma) \Big[ \big( r_{1_{c}} t_{2} \big)^{2} + \big( t_{1} r_{2_{c}} \big)^{2} - 2 r_{1_{c}} r_{2_{c}} t_{1} t_{2} \cos{(2 \, \pi \, \sigma \, x)} \Big] d\sigma \\ &= \Big[ \big( r_{1_{c}} t_{2} \big)^{2} + \big( t_{1} r_{2_{c}} \big)^{2} \Big] I_{SSW}(0) - 2 \int\limits_{0}^{\infty} \Big[ r_{1_{c}} r_{2_{c}} t_{1} t_{2} \Big] B(\sigma) \cos{(2 \, \pi \, \sigma \, x)} \, d\sigma \\ &= I_{SSW-Offset} + I_{SSW-Modulated}(x) \end{split}$$

#### Equation A.13.

$$\begin{split} I_{SLW}(x) &= \int\limits_{0}^{\infty} I_{SLW}(x,\sigma) d\sigma \\ &= \int\limits_{0}^{\infty} E_{0}^{2}(\sigma) \Big[ \big( r_{1_{c}} r_{2_{i}} \big)^{2} + \big( t_{1} t_{2} \big)^{2} + 2 r_{1_{c}} r_{2_{i}} t_{1} t_{2} \cos{(2 \pi \sigma x)} \Big] d\sigma \\ &= \Big[ \big( r_{1_{c}} r_{2_{i}} \big)^{2} + \big( t_{1} t_{2} \big)^{2} \Big] I_{SSW}(0) + 2 \int\limits_{0}^{\infty} \Big[ r_{1_{c}} r_{2_{i}} t_{1} t_{2} \Big] B(\sigma) \cos{(2 \pi \sigma x)} d\sigma \\ &= I_{SLW-Offset} + I_{SLW-Modulated}(x) \end{split}$$

Taken together, the overall intesity of the radiation measured by the SPIRE spectrometer detectors is given by the following:

#### Equation A.14.

$$I_{TOTAL}(x) = I_{Source}(x) + I_{Telescope}(x) + I_{SCAL}(x) + I_{SCAL2}(x) + I_{SCAL4}(x)$$

#### 1. SSW Detectors.

#### Equation A.15.

$$\begin{split} I_{\mathit{SSW}}(x) &= & \big(I_{\mathit{Source}}(0) + I_{\mathit{Telescope}}(0)\big) \Big[ \big(r_{1_i} r_{2_e}\big)^2 + \big(t_1 t_2\big)^2 \Big] + \big(I_{\mathit{SCAL}}(0) + I_{\mathit{SCALZ}}(0) + I_{\mathit{SCALZ}}(0)\big) \Big[ \big(r_{1_e} t_2\big)^2 + \big(t_1 r_{2_e}\big)^2 \Big] \\ &+ 2 \int\limits_{0}^{\infty} \big[r_{1_i} r_{2_e} t_1 t_2\big] B_{\mathit{Source}}(\sigma) \cos(2\pi\sigma x) \, d\sigma + 2 \int\limits_{0}^{\infty} \big[r_{1_i} r_{2_e} t_1 t_2\big] B_{\mathit{Telescope}}(\sigma) \cos(2\pi\sigma x) \, d\sigma \\ &- 2 \int\limits_{0}^{\infty} \big[r_{1_e} r_{2_e} t_1 t_2\big] B_{\mathit{SCALZ}}(\sigma) \cos(2\pi\sigma x) \, d\sigma - 2 \int\limits_{0}^{\infty} \big[r_{1_e} r_{2_e} t_1 t_2\big] B_{\mathit{SCALZ}}(\sigma) \cos(2\pi\sigma x) \, d\sigma \\ &- 2 \int\limits_{0}^{\infty} \big[r_{1_e} r_{2_e} t_1 t_2\big] B_{\mathit{SCALA}}(\sigma) \cos(2\pi\sigma x) \, d\sigma \end{split}$$

#### 2. SLW Detectors.

**Equation A.16.** 

$$\begin{split} I_{\mathit{SLW}}(x) &= & \big(I_{\mathit{Source}}(0) + I_{\mathit{Telescope}}(0)\big) \Big[ \big(r_{1_i}t_2\big)^2 + \big(t_1r_{2_i}\big)^2 \Big] + \big(I_{\mathit{SCAL}}(0) + I_{\mathit{SCALZ}}(0) + I_{\mathit{SCALZ}}(0)\big) \Big[ \big(r_{1_\epsilon}r_{2_i}\big)^2 + \big(t_1t_2\big)^2 \Big] \\ &- 2\int\limits_0^\infty \Big[ r_{1_\epsilon}r_{2_i}t_1t_2 \Big] B_{\mathit{Source}}(\sigma) \cos(2\,\pi\,\sigma\,x) \, d\,\sigma - 2\int\limits_0^\infty \Big[ r_{1_\epsilon}r_{2_i}t_1t_2 \Big] B_{\mathit{Telescope}}(\sigma) \cos(2\,\pi\,\sigma\,x) \, d\,\sigma \\ &+ 2\int\limits_0^\infty \Big[ r_{1_\epsilon}r_{2_\epsilon}t_1t_2 \Big] B_{\mathit{SCALZ}}(\sigma) \cos(2\,\pi\,\sigma\,x) \, d\,\sigma + 2\int\limits_0^\infty \Big[ r_{1_\epsilon}r_{2_i}t_1t_2 \Big] B_{\mathit{SCALZ}}(\sigma) \cos(2\,\pi\,\sigma\,x) \, d\,\sigma \\ &+ 2\int\limits_0^\infty \Big[ r_{1_\epsilon}r_{2_i}t_1t_2 \Big] B_{\mathit{SCALA}}(\sigma) \cos(2\,\pi\,\sigma\,x) \, d\,\sigma \end{split}$$

## A.3. Double-sided and Single-sided Interferograms

The terms double-sided and single-sided as used in this document describe the two types of interferograms that can be measured with a Fourier Transform Spectrometer.

## A.3.1. Double-sided Interferograms

Double-sided interferograms are defined as those interferograms or that portion of measured interferogram where the sample *positions* are symmetric about the position of zero path difference (ZPD). That is, a double-sided interferogram is one that contains an equal number of samples before and after the ZPD sample <sup>2</sup>. An envelope of a double-sided interferogram is shown in Figure A.2.

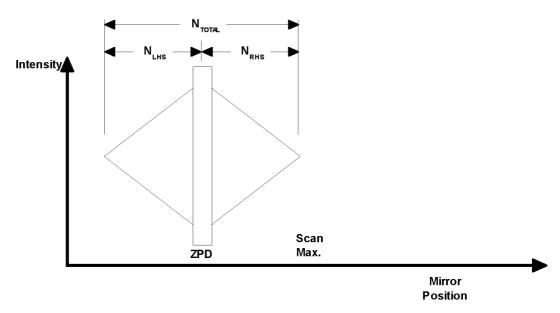


Figure A.2. Envelope of a double-sided interferogram

## A.3.2. Single-sided Interferograms

Single-sided interferograms are defined as those interferograms that contain more samples on one side of ZPD than the other. An envelope of a single-sided interferogram is shown in Figure A.3.

 $<sup>\</sup>frac{1}{2}$  Some implementations of the Fourier Transform may require an even number of points ( $N_{TOTAL}$  even). In this case, the RHS of the double-sided interferogram will contains an extra point to render the total number of points even.

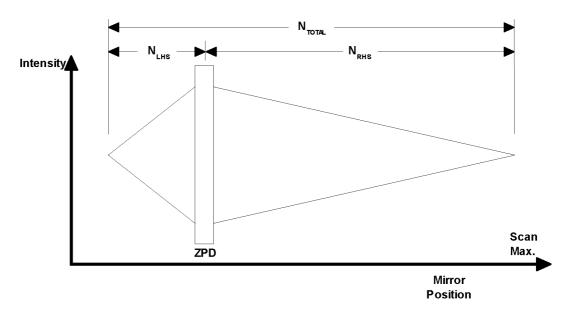


Figure A.3. Envelope of a single-sided interferogram